

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/562,400 Confirmation No. : 8481
First Named Inventor : Hiroshi Kannan
Filed : April 25, 2006
TC/A.U. : 1792
Examiner : Mahmoud Dahimene
Docket No. : 010986.57272US
Customer No. : 23911
Title : PLASMA GENERATION METHOD, CLEANING
METHOD, AND SUBSTRATE PROCESSING METHOD

REPLY TO OFFICE ACTION

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the final Office Action December 4, 2008.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 21 of this paper.